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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/601,007	06/20/2003	Satoshi Masaoka	AK-419XX	5771

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WEINGARTEN, SCHURGIN, GAGNEBIN & LEOVICI LLP  
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BOSTON, MA 02109

EXAMINER
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CONLEY, SEAN EVERETT

ART UNIT	PAPER NUMBER
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1744

MAIL DATE	DELIVERY MODE
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07/13/2007

PAPER

**Please find below and/or attached an Office communication concerning this application or proceeding.**

The time period for reply, if any, is set in the attached communication.

**Office Action Summary**

Application No.

10/601,007

Applicant(s)

MASAOKA ET AL.

Examiner

Sean E. Conley

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-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

**Period for Reply**

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

**Status**

- 1) ☒ Responsive to communication(s) filed on 3/12/2007, 4/24/2007.
- 2a) ☒ This action is **FINAL**. 2b) ☐ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

**Disposition of Claims**

- 4) ☒ Claim(s) 7-13, 29 and 33 is/are pending in the application.
- 4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.
- 5) ☐ Claim(s) \_\_\_\_\_ is/are allowed.
- 6) ☒ Claim(s) 7-13, 29, and 33 is/are rejected.
- 7) ☐ Claim(s) \_\_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

**Application Papers**

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☒ The drawing(s) filed on 20 June 2003 is/are: a) ☒ accepted or b) ☐ objected to by the Examiner.  
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

**Priority under 35 U.S.C. § 119**

- 12) ☒ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☒ All b) ☐ Some \* c) ☐ None of:
1. ☒ Certified copies of the priority documents have been received.
  2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
  3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

\* See the attached detailed Office action for a list of the certified copies not received.

**Attachment(s)**

- |  |   |
|--|---|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892)  | 4) <input type="checkbox"/> Interview Summary (PTO-413)<br>Paper No(s)/Mail Date. _____ |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)   | 5) <input type="checkbox"/> Notice of Informal Patent Application                       |
| 3) <input checked="" type="checkbox"/> Information Disclosure Statement(s) (PTO/SB/08)<br>Paper No(s)/Mail Date <u>3/12/2007</u> . | 6) <input type="checkbox"/> Other: _____  |

## DETAILED ACTION

### *Response to Amendment*

1. The amendment filed April 24, 2007 and the information disclosure statement filed March 12, 2007 have been received and considered. Claims 7-13, 29 and 33 remain pending.

### *Claim Rejections - 35 USC § 103*

2. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.
3. Claims 7-9, 12, and 29 are rejected under 35 U.S.C. 103(a) as being unpatentable over Menashi in view of Perruchot et al. (Patent Application Publication 2004/0037736 A1).

Regarding claims 7-9, and 29 Menashi discloses a method of sterilizing surfaces of containers (packaging material) by exposing the surfaces to a plasma for a time sufficient to destroy the microorganisms (see col. 1, lines 10-20; figure 3). The device comprises a high voltage pulse power source (power supply (19)), a discharge side electrode (18) attached to the power supply (19), a ground side electrode (22) arranged so as to be opposed to the discharge side of the discharge side electrode (18), and an argon gas inlet conduit (31). The surfaces of the container are placed between the electrodes and the surfaces are sterilized by applying high voltage pulses to the

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discharge electrode (18) which generates plasma in the argon gas atmosphere under atmospheric conditions (see figure 3; see col. 2, lines 38-72; see col. 3, lines 58-68; see col. 4, lines 45-73). Menashi fails to teach the step of giving water or an aqueous solution to the packaging material before discharge, during discharge or before and during discharge.

Perruchot et al. disclose a plasma sterilization system that sterilizes surfaces of articles using plasma generated from a corona discharge produced by electrodes in the presence of oxygen, nitrogen, or hydrogen gas (see paragraphs [0016]-[0017], [0024], [0046]. The process improves on conventional plasma sterilization systems by humidifying the oxygen, nitrogen, or hydrogen gas prior to introducing the gas in the discharge zone of the electrodes (see paragraph [0046]). The process gas flows from a source (12) through a humidification chamber (14) where the gas is supplied with water vapor (see paragraphs [0054], [0059] and [0084]). The discharge of the plasma and the humidification of the gas are simultaneous (see paragraph [0024]). The resulting humidification of the gas provides a higher humidity in the vicinity of the article which results in shorter sterilization times and also decreases the temperature of the surfaces of the article being treated which prevents a decrease in the sterilization effects caused by heating of the article due to plasma exposure (see paragraph [0078], see table 2). Although it is not specifically recited, the water vapor present in the plasma forming gas (e.g. oxygen, nitrogen, or hydrogen) will cloud the surface of the article being treated when the humidified gas is introduced to the article. Perruchot et al. further disclose

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that plasma sterilization is effective on wet articles (see paragraph [0079]). Thus, it is known to sterilize a wet article using plasma.

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the process of Menashi and provide a container that is wet and which is to be sterilized by plasma since Perruchot et al. disclose that plasma sterilization of surfaces is effective on wet articles. Furthermore, a wet container will have a clouded surface and the wet surface of the container will humidify the surrounding gas (air) before discharge.

Regarding claim 12, Menashi discloses a process for sterilizing containers by generating a plasma (see col. 1, lines 10-20, col. 1, line 69-col. 2, line 8).

4. Claim 10 is rejected under 35 U.S.C. 103(a) as being unpatentable over Menashi in view of Perruchot et al. as applied to claim 7 above, and further in view of Nam et al.

The combination of Menashi and Perruchot et al. fail specifically to teach a discharge side electrode provided with unevenness having continuous projections on the discharge side surface of the electrode.

Nam et al. discloses an apparatus for generating a low temperature plasma at atmospheric pressure that includes a discharge electrode (conductor electrode (5)) provided with unevenness having continuous projections (tips (8, 8', 8'')) along the length of the electrode (5) as shown in figures 3A-3C. These continuous projections facilitate the discharging of the charges which are accumulated in the electrode (see paragraph [0029]).

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the invention of Menashi and include continuous projections on the discharge electrode (18) in order to facilitate and the release of the charges accumulated with the electrode as taught by Nam et al.

5. Claim 11 is rejected under 35 U.S.C. 103(a) as being unpatentable over Menashi in view of Perruchot et al. as applied to claim 7 above, and further in view of Dusevoir.

Menashi and Perruchot et al. disclose the claimed invention except for a discharge electrode with a surface that is helical.

Dusevoir discloses a discharge electrode (34') for generating a corona discharge that includes an outer sheath (48') having integral ribs (54') helically formed. The helical ribs increase the corona discharge of the electrode (34') by increasing the effective area of the ribs (see col. 2, lines 58-66; see figure 4). Furthermore, the use of long thin solid wire electrodes tend to break easily due to concentration of electrical discharge at certain points thereon and due to material fatigue (see col. 1, lines 25-38).

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the invention of Menashi and provide a discharge electrode having helical ribs as taught by Dusevoir in order to increase the corona discharge of the electrode and also provide an electrode that will not easily break by using the helical ribs to evenly distribute the corona discharge throughout the electrode.

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6. Claim 13 is rejected under 35 U.S.C. 103(a) as being unpatentable over Menashi in view of Perruchot et al. as applied to claim 7 above, and further in view of Vavilin et al.

The combination of Menashi and Perruchot et al. disclose the claimed invention except for a discharge electrode that is inserted into the container being sterilized.

Vavilin et al. discloses a method of sterilizing containers by generating plasma. Two electrodes (5 and 6) are arranged coaxially and are fixed to an insulating plate (17) and connected to a high voltage power supply (3). The electrode (5) is placed centrally within the container to be treated (flask (8)) and the other electrode (6) is located outside of the container. A gas source (4) is also in communication with the inside of the flask (8) for providing the flask (8) with a plasma actuating medium (e.g. argon gas) (see figure 5; page 13, lines 7-17). In use, the power source (3) excites an electric discharge between the electrodes (5) and (6) at atmospheric pressure. The argon gas is fed from source (4) to the region inside the flask (8) where the discharge occurs thus forming plasma in the flask (8) (see page 3, lines 1-20; see page 4, lines 11-19; see page 9, lines 8-10).

Therefore, it would have been an obvious matter of design choice to modify the method of Menashi and place the discharge electrode inside the container and the ground electrode outside of the container since Vavilin et al. discloses that the discharge electrode can be located either inside or outside of the container and still generate a plasma sufficient to sterilize the surfaces of the container.

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7. Claim 33 is rejected under 35 U.S.C. 103(a) as being unpatentable over Menashi in view of Perruchot et al. as applied to claim 29 above, and further in view of Dusevoir and Vavilin et al.

The combination of Menashi and Perruchot et al. disclose the claimed invention except for a discharge electrode which has unevenness in the form of continuous projections that are helical in shape. Menashi and Perruchot et al. also fail to teach a discharge electrode that is inserted into the container being sterilized.

Dusevoir discloses a discharge electrode (34') for generating a corona discharge that includes an outer sheath (48') having integral ribs (54') helically formed. The helical ribs increase the corona discharge of the electrode (34') by increasing the effective area of the ribs (see col. 2, lines 58-66; see figure 4). Furthermore, the use of long thin solid wire electrodes tend to break easily due to concentration of electrical discharge at certain points thereon and due to material fatigue (see col. 1, lines 25-38).

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the invention of Menashi and provide a discharge electrode having helical ribs as taught by Dusevoir in order to increase the corona discharge of the electrode and also provide an electrode that will not easily break by using the helical ribs to evenly distribute the corona discharge throughout the electrode.

Vavilin et al. discloses a method of sterilizing containers by generating plasma. Two electrodes (5 and 6) are arranged coaxially and are fixed to an insulating plate (17) and connected to a high voltage power supply (3). The electrode (5) is placed centrally



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within the container to be treated (flask (8)) and the other electrode (6) is located outside of the container. A gas source (4) is also in communication with the inside of the flask (8) for providing the flask (8) with a plasma actuating medium (e.g. argon gas) (see figure 5; page 13, lines 7-17). In use, the power source (3) excites an electric discharge between the electrodes (5) and (6) at atmospheric pressure. The argon gas is fed from source (4) to the region inside the flask (8) where the discharge occurs thus forming plasma in the flask (8) (see page 3, lines 1-20; see page 4, lines 11-19; see page 9, lines 8-10).

Therefore, it would have been an obvious matter of design choice to modify the method of Menashi and place the discharge electrode inside the container and the ground electrode outside of the container since Vavilin et al. discloses that the discharge electrode can be located either inside or outside of the container and still generate a plasma sufficient to sterilize the surfaces of the container.

### ***Response to Arguments***

8. Applicant's arguments, see pages 8-15, filed April 24, 2007, with respect to the rejection of the claims under 103(a) have been considered but are moot in view of the new ground(s) of rejection. The applicant's amendment necessitated the new grounds of rejection. The previously cited reference of Menashi has again been relied upon to teach the same claimed features as stated in the previous office action mailed on January 24, 2007. Furthermore, the previously cited reference of Perruchot et al. has

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been relied upon in this office action to teach that it is well known to sterilize wet articles using a plasma generated from a high voltage discharge electrode.

9. Applicant's arguments, see pages 6-7, filed April 24, 2007, with respect to the claim rejections under 35 U.S.C. 112, second paragraph have been fully considered and are persuasive. The rejection has been withdrawn. In the response the applicant has clearly defined the term "normal" to mean what temperature or pressure normally exists in a room. Thus the term "normal" is definite and is interpreted to be any known temperature or pressure that may exist in a room

### ***Conclusion***

10. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

- U.S. Patent No. 4,680,163 to Blidschun et al.

11. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire **THREE MONTHS** from the mailing date of this action. In the event a first reply is filed within **TWO MONTHS** of the mailing date of this final action and the advisory action is not

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mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Sean E. Conley whose telephone number is 571-272-8414. The examiner can normally be reached on M-F 8:30-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gladys Corcoran can be reached on 571-272-1214. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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/Gladys Corcoran/  
Supervisory Patent Examiner  
Art Unit 1744

July 7, 2007